



Docket No.: 0756-7258

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Koichiro TANAKA )  
Serial No. 10/787,191 ) Group Art Unit: 2828  
Filed: February 27, 2004 ) Examiner: Minsun Harvey  
For: LASER IRRADIATION APPARATUS, )  
LASER IRRADIATION METHOD, AND )  
METHOD FOR MANUFACTURING )  
SEMICONDUCTOR DEVICE )

**CERTIFICATE OF MAILING**

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*Kimberly L. Lurie*

**REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson  
Reg. No. 38,285

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